



# ***Space Qualification of GaN HEMTs - Guidance Document Announcement***

***John Scarpulla  
Caroline Gee***

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- GaN HEMTs / MMICs have not yet been “officially” space qualified
  - *A number of Class A & B missions have targeted GaN power HEMT technology for usage in the next few years*
  - *Exciting opportunities for applications such as SSPAs, High Intercept LNAs*
- Existing techniques for accelerated testing and qual (as for GaAs) are inadequate:
  - *GaN may not have a single dominant failure mode*
  - *Temperatures/voltages/power densities are generally much higher*
  - *DC stressing alone may not be sufficient*
- In early 2017 an Aerospace draft document was written
  - *ATR-2017-01782 “DRAFT – Guidelines for Space Qualification of GaN HEMT Technology” J. Scarpulla & C. Gee, May 23, 2017*
- A working group was established to mature this document
  - *7 months of weekly meetings*
  - *Approx. 85 members / interested parties*
  - *Extensive edits and revisions were made based on many inputs*

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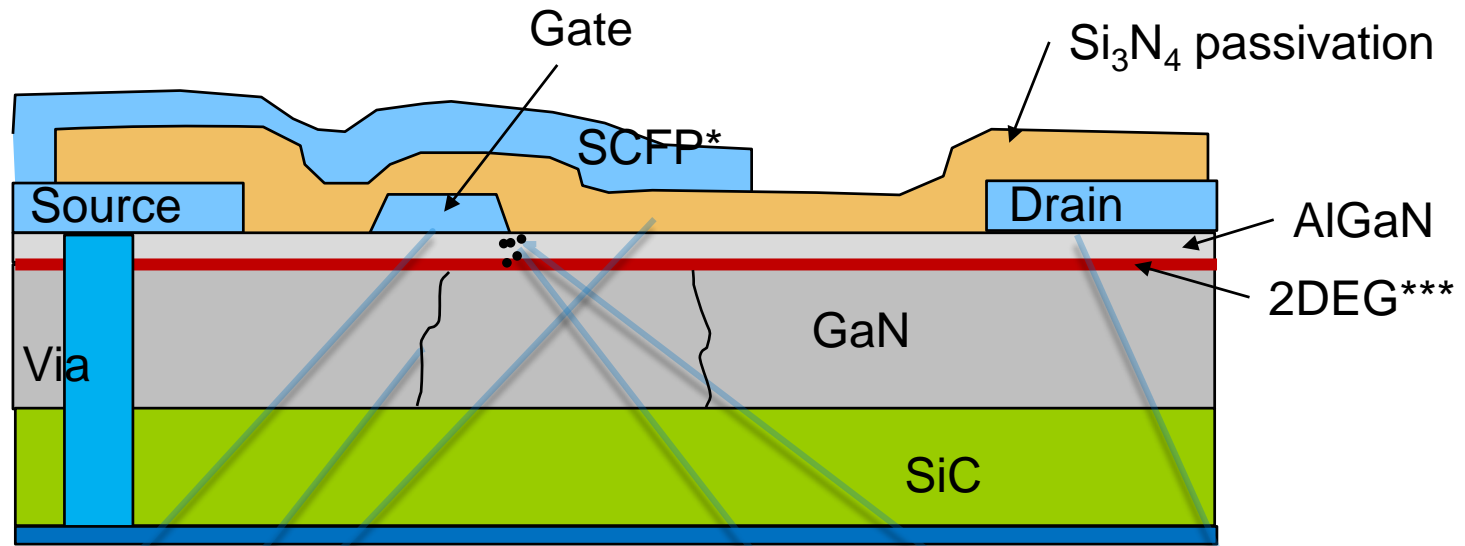
# Is GaN “different”?

*Well, yes...*

- We *cannot* qualify GaN devices in a similar way to previous III-V semiconductors (GaAs, InP)
  - *Multiple failure mechanisms may exist*
  - *(they exist in GaAs too, but the lower voltages/currents/power levels preclude them)*
  - *Gate sinking no longer remains as dominant*
- In our new document we focus on:
  - *microwave/power HEMTs and MMICs*
    - Conventional Schottky gates
    - No enhancement mode devices (very different physics)
    - Typically (but not limited to) SiC substrates
- Qual methods
  - *Intrinsic failure modes*
    - DC multi-temperature lifetests, at multiple bias points
      - *Step-stress / constant stress*
    - RF-driven tests
      - *CW / pulsed*
      - *TLYF (test like you fly)*

***Multiple modes demand multiple tests***

# Some Failure Mechanisms in GaN Power HEMTs



## Reliability Concerns:

- Gate diffusion, chemical reactions
- Source/drain ohmic metal-semiconductor reactions
- Pits/cracks – moisture / mechanical stress (IPE\*\*)
- Charging/traps- virtual gate (VG)
- Dislocation defects (throughout)
- Point defects (esp. at gate-drain edge)

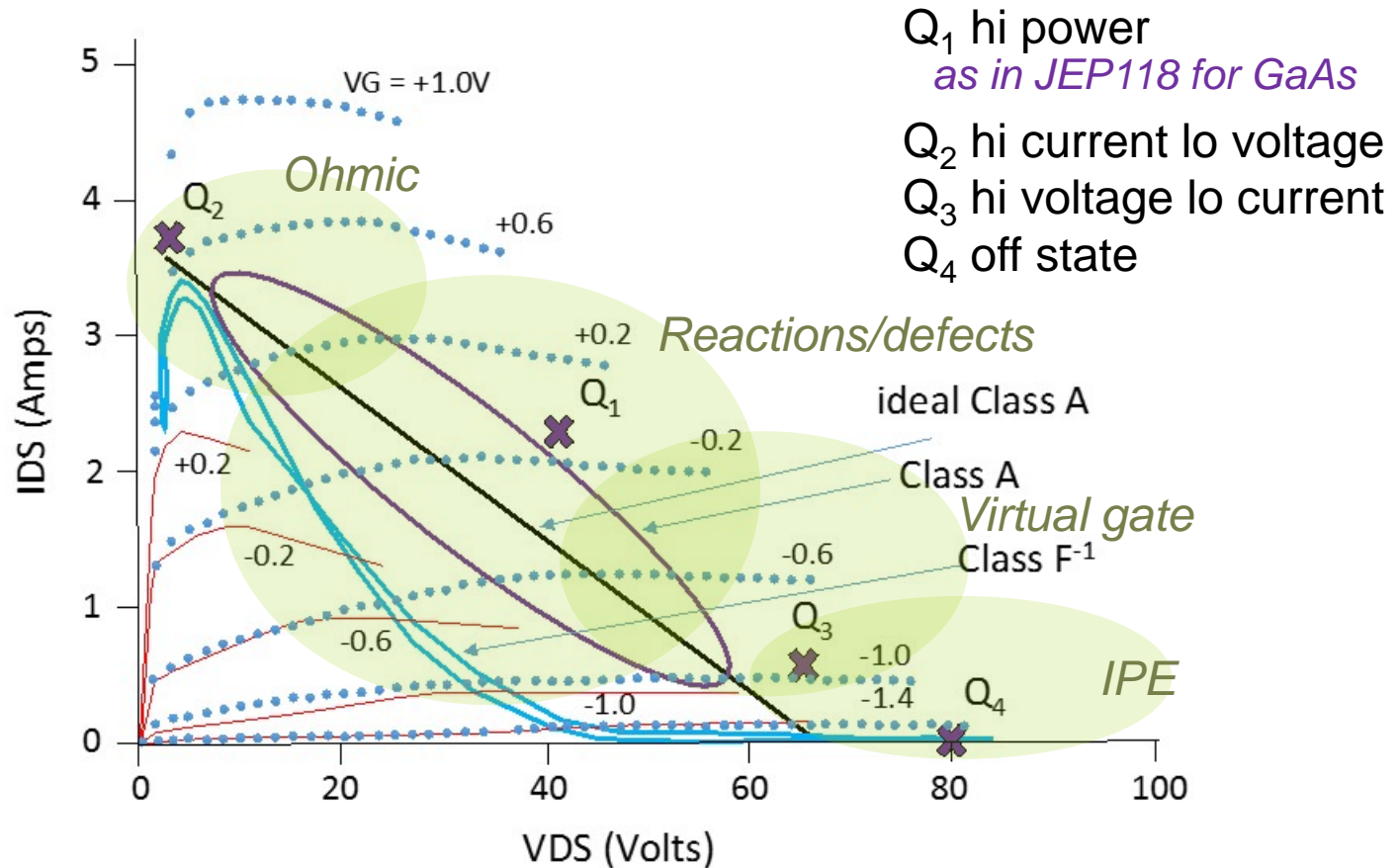
\*Source Connected Field Plate

\*\*Inverse Piezoelectric Effect

\*\*\*Two Dimensional Electron Gas

# Stressing regimes

DC stressing at four operating points (Q-points)



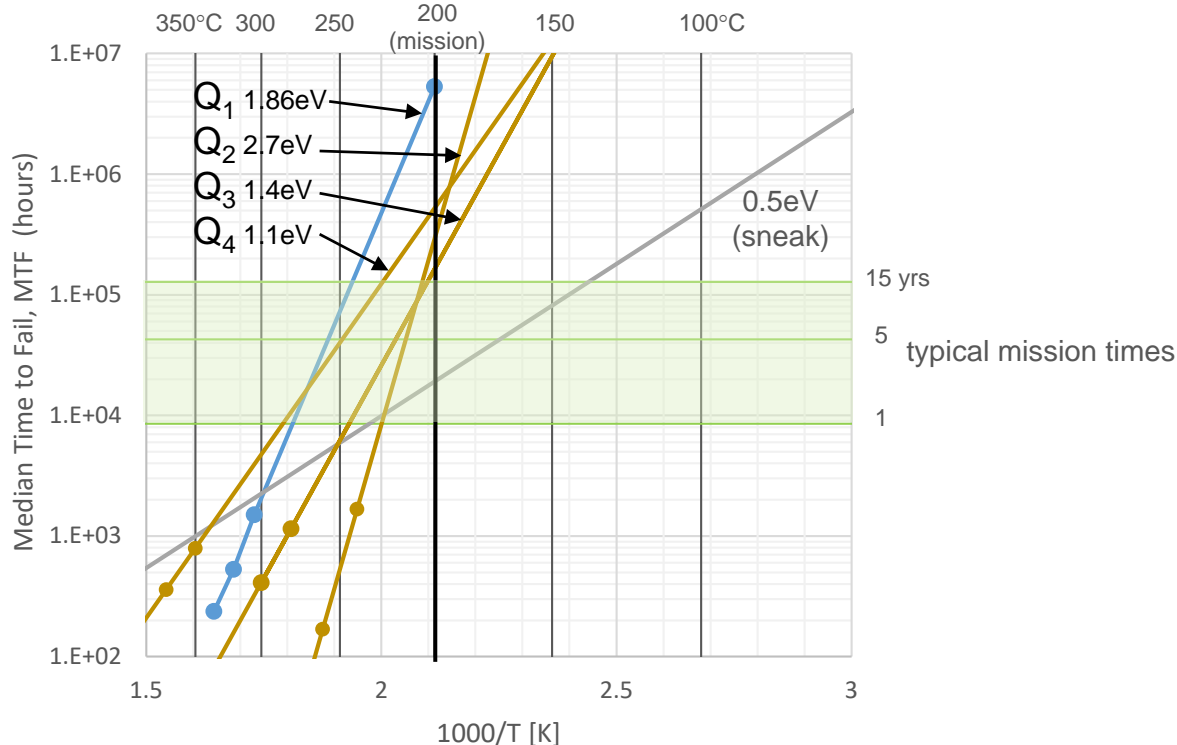
- Depending upon the RF load figure different failure modes are manifested
- Devote at least two temperatures to each Q-point



# Multiplicity of Intrinsic Failure Modes

*With operation over different bias points*

- DC lifestest data taken at operating point  $Q_1$ 
  - predicts  $E_A = 1.86\text{eV}$ ,  $MTTF = 5 \times 10^6$  hrs at mission temperature  $250^\circ\text{C}$ .
- CAVEATS:
  - $Q_2 - Q_4$  give much shorter MTTFs
  - A “sneak” low  $E_A$  mechanism of  $0.5\text{eV}$  could exist - short MTTF

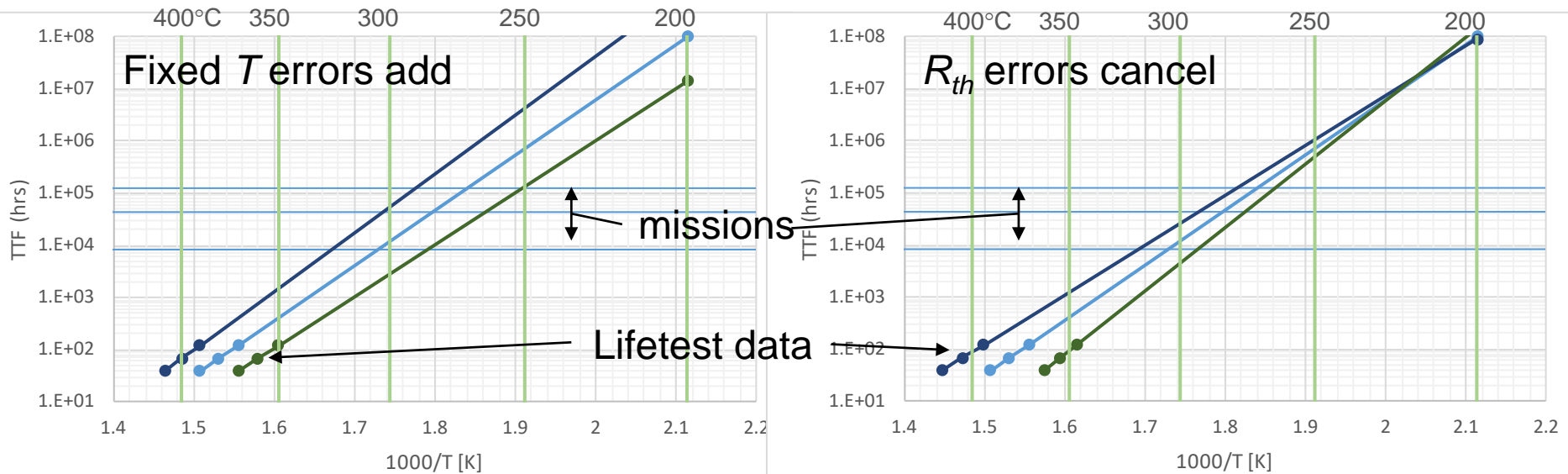


**Guidelines are provided for comprehensive test campaigns**

# Temperature Errors Affect Reliability Predictions

*Temperatures are much higher in GaN power HEMTs*

- Methods of temperature measurement – guidelines provided
  - IR thermography
  - Raman scattering
    - Bulk - direct
    - Surface – with nanoparticle sprinkling
  - Thermorefectance
  - Gate end-end resistance measurement
  - Translation from stress power level to usage power level using  $R_{th}$  can introduce additional temperature errors and reliability prediction uncertainties



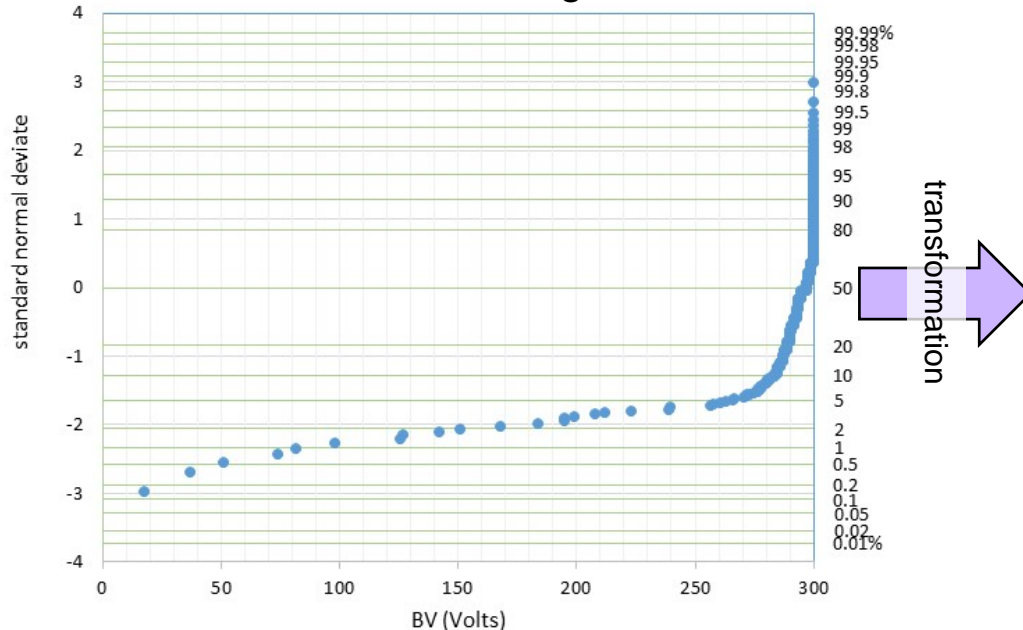
**Temperature errors have varied effects- guidelines are provided**

# Defects

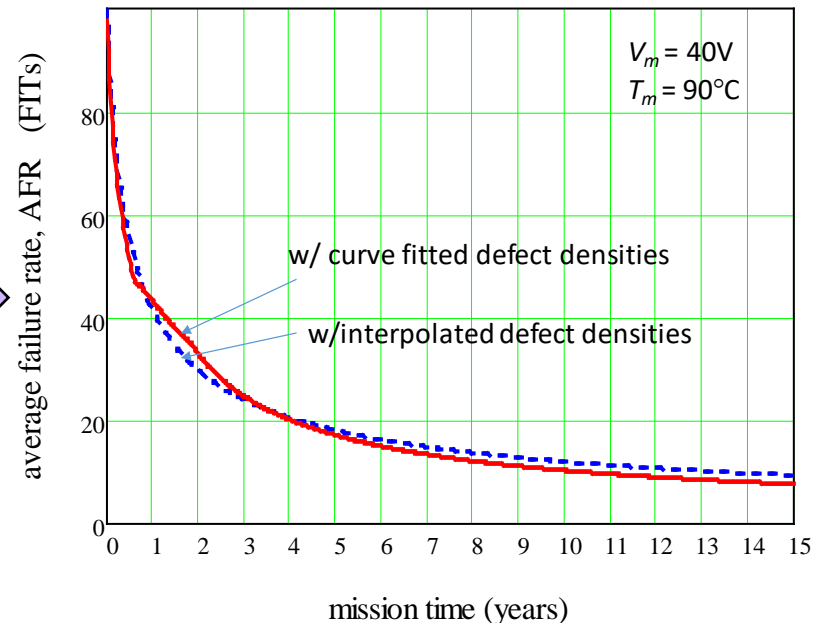
Guidance provided on reliability assessment of process defects

- Example – defects in MIMCAPs
  - MIMCAPs in GaN technology subjected to much higher voltage than in previous GaAs technology – MIMCAPs may dominate failure rates

Probplot of ramped breakdown voltages



FIT rate vs. time



Guidance provided on MIMCAP defect density testing and reliability prediction



# **More Recommendations & Test Protocols**

*Topics to consider for space qualification of GaN*

- Robustness
  - SOA (safe operating area)
  - Gate burnout
  - RF burnout
  - ESD
  - Temperature cycling
  - Power cycling
  - Off-state voltage screening
- Intrinsic Reliability
  - DC lifetesting (4 Q-points)
  - RF lifetesting
  - Step stressing
  - TLYF (Test Like You Fly)
  - Thin film resistors
  - Electromigration
- Environmental Effects
  - Moisture sensitivity
  - Hydrogen sensitivity
  - Air Sensitivity
- Extrinsic Defects
  - MIMCAPs
  - Gate Defects
  - Airbridge Defects
  - Backside Via defects
- Mechanical
  - Backside metal adhesion
  - Bondpull tests
  - Die shear tests
  - Step Coverage
  - Low Frequency Oscillations
- Radiation Effects
  - Total Ionizing Dose
  - Dose Rate
  - Single Event Effects
  - Displacement Damage

***Guidelines are provided on these topics and more***

# Conclusion



- A peer-reviewed and vetted space qualification methodology for GaN power HEMTs and MMICs is now available
- TOR-2018-00691 “Guidelines for Space Qualification of GaN HEMT Technologies” J. Scarpulla, C. Gee
- For more information please contact
  - *john.scarpulla@aero.org*
  - *caroline.gee@aero.org*
- **THANK YOU!**